

Appl. No. 10/716,814
Amdt. dated April 25, 2006
Reply to Office action of January 25, 2006

Attorney Docket No.: N1161-00025

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/716,814

Confirmation No.: 7199

In re application of: Phong Nguyen et al.

Filed: November 19, 2003

Technology Center/Art Unit: 2877

Examiner: Isiaka O. Akanbi

Docket No.: N1161-00025

Customer No.: **08933**

Title: WAFER STAGE POSITION
CALIBRATION METHOD AND SYSTEM

Mail Stop Amendment
Commissioner for Patents
5 P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

10 Responsive to the Office Action dated **January 25, 2006**, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.